



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(211.001-D2-US)

In re Application of: **FAZAN ET AL.**

Serial No: **10/724,377**

U.S. Filing Date: **NOVEMBER 28, 2003**

Title: **SEMICONDUCTOR DEVICE**

)  
)  
) Group Art Unit: **2822**

) Examiner:  
)  
)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 26, 2004

Michiko Sato  
Date  
(person signing this certificate)

Michiko Sato  
Signature

**SECOND PRELIMINARY AMENDMENT**

Dear Sir:

Preliminary to the examination of the above-referenced application, kindly amend the application as follows: